

## PATENT ASSIGNMENT COVER SHEET

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<b>City:</b>	Arlington
<b>State/Country:</b>	VIRGINIA
<b>Postal Code:</b>	22230
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<b>CORRESPONDENCE DATA</b>	
<b>Fax Number:</b>	(703)292-9041
<i>Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.</i>	
<b>Email:</b>	nsfpatents@nsf.gov
<b>Correspondent Name:</b>	NATIONAL SCIENCE FOUNDATION
<b>Address Line 1:</b>	4201 WILSON BLVD
<b>Address Line 2:</b>	ROOM 1265
<b>Address Line 4:</b>	ARLINGTON, VIRGINIA 22230
<b>NAME OF SUBMITTER:</b>	DANA THIBODEAU
<b>SIGNATURE:</b>	/DMT/
<b>DATE SIGNED:</b>	07/22/2015
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Invention Title: High Resolution Surface Measurement with GelSight

Inventor(s): Edward H. Adelson, Micah Kimo Johnson

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Patent or Application Serial No.: 13/5617,12

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Foreign Applications filed/intended in (countries): \_\_\_\_\_

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Signed this 7th day of August, 20 12.

By Rolande Johndro

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For MASSACHUSETTS INSTITUTE OF TECHNOLOGY

(Grantee/Contractor Organization)

At MIT Technology Licensing Office NE18-501 One Cambridge Center, Kendall Square

Cambridge, MA 02142 US

(Business Address)